IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

JUN 2 5 2002

APPLICANT: Anisul Khan et al.

SERIAL NO.: 09/740,146

FILED: December 18, 2000

FOR: APPARATUS FOR PERFORMING

SELF-CLEANING METHOD

OF FORMING DEEP TRENCHES

IN SILICON SUBSTRATES

Group Art Unit:

1763

Examiner:

Unknown

Docket No.:

AM-3396.D1

June 25, 2002

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REQUEST FOR CORRECTED FILING RECEIPT TRANSMITTAL LETTER

TC 1700

Commissioner for Patents Washington, DC 20231

Sir:

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CERTIFICATE OF MAILING (37 CFR § 1.10)

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Date: June 25, 2002

Shirley L. Church, Reg. No. 31,858

1. Church

This transmittal letter is submitted in duplicate for accounting purposes.

Respectfully submitted,

Shirley L. Church

Registration No. 31,858

Attorney for Applicants

(408) 245-5109

Correspondence Address: Patent Counsel Applied Materials, Inc. P.O. Box 450A Santa Clara, CA 95052



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CONFIRMATION NO. 4163

Bib Data Sheet									
SERIAL NUMBE 09/740,146			CLASS 156		GROUP ART 0 1763		UNII DO		ATTORNEY OCKET NO. M-3396.D1
Ajay Kumar Jeffrey D. C Dragan Poo ** CONTINUING I THIS APPL ** FOREIGN APP IF REQUIRED, FO	ICATION IS A D	A; y, CA; o, CA; DIV OF 09/4	***		T 6,318,	384 G	RI	_	EIVED 2- 2002 1700
** 06/05/2001 Foreign Priority claimed 35 USC 119 (a-d) cond met Verified and Acknowledged ADDRESS Patent Counsel Applied Materials (P.O. Box 450 A	itions yes Allowance Examiners Signs	no Met af	ter iitials	STATE OR COUNTRY CA	SHE DRAV 1	VING	TOT/ CLAII 19	MS	INDEPENDEN CLAIMS 1
Santa Clara ,CA TITLE Apparatus for per		aning metho	od of form	ning deep tren	ches in s	silicon s	substrate	es	
RECEIVED	RECEIVED No to charge/credit DEPOSIT ACCOUNT					☐ All Fees ☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. time) ☐ 1.18 Fees (Issue) ☐ Other ☐ Credit			

Attorney Docket No. AM-6.D

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ATTY.DOCKET.NO DRAWINGS APPLICATION NUMBER FILING DATE **GRP ART UNIT** FIL FEE REC'D TOT CLAIMS IND CLAIMS 1763 710 AM-3396.D1 19 12/18/2000 11 09/740.146

CONFIRMATION NO. 4163

FILING RECEIPT

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Patent Counsel Applied Materials, Inc. P.O. Box 450 A Santa Clara, CA 95052 RECO 100 11 2001

Date Mailed: 06/06/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Anisul Khan, Sunnvvale, CA: Ajay Kumar, Sunnyvale, CA; Jeffrey D. Chinn, Forster City, CA, FOSTER CITY, CA Dragan Podlesnik, Palo Alto, CA;

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TC 1700

Assignment For Published Patent Application

Applied Materials, Inc., Santa Clara, CA;

Domestic Priority data as claimed by applicant

THIS APPLICATION IS A DIV OF 09/405,349 09/24/1999

Foreign Applications

If Required, Foreign Filing License Granted 06/05/2001

Projected Publication Date: 09/13/2001

Non-Publication Request: No

Early Publication Request: No

JUN 1 3 2001

Title

Apparatus for performing self cleaning method of forming deep trenches in silicon substrates

Preliminary Class

156

Data entry by : MILANI, JALEH

Team : OIPE

Date: 06/06/2001



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